



Attorney Docket No. 0756-7171

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Akihisa SHIMOMURA et al.

Serial No. 10/607,542

Filed: June 27, 2003

For: METHOD OF MANUFACTURING A
SEMICONDUCTOR DEVICE

) Group Art Unit: 2812

) Examiner: Stanetta D. Isaac

) CERTIFICATE OF MAILING

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Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, Applicant submits herewith a Form PTO-1449 listing references known to Applicant and requests that these references be made of record in the above identified application. Copies of the references listed are submitted herewith in accordance with 37 C.F.R. 1.98(a).

The requisite \$180.00 fee is enclosed.

Respectfully submitted,

Eric J. Robinson
Reg. No. 38,285

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Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>		Complete if Known	
		Application Number	10/607,542
		Filing Date	June 27, 2003
		First Named Inventor	Akihisa SHIMOMURA et al.
		Group Art Unit	2812
		Examiner Name	Stanetta Isaac
		Attorney Docket Number	0756-7171
Sheet	1	1	1

U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
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Examiner Initials [*]	Cite No. ¹	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Office ³	Number ⁴	Kind Code ⁵ (if known)				
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OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS			
Examiner Initials [*]	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
		Suga et al., "P-3: The Effect of a Laser Annealing Ambient on the Morphology and TFT Performance of Poly-Si Films" SID Digest '00, SID International Symposium Digest of Technical Papers, 01/01/2000, pp. 534-537	

Examiner Signature	Date Considered
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.